

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: SEMICONDUCTOR DEVICE AND
METHOD FOR MACHINING A
SEMICONDUCTOR SUBSTRATE
Attorney Docket Number:: 243938US2
Total Drawing Sheets:: 4

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: JAPAN
Status:: FULL CAPACITY
Given Name:: Tohru
Family Name:: KOYAMA
City of Residence:: TOKYO
Country of Residence:: JAPAN
Street of Mailing Address:: c/o Renesas Technology Corp., 4-1,
Marunouchi 2-chome, Chiyoda-ku
City of Mailing Address:: TOKYO
Country of Mailing Address:: JAPAN

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: JAPAN
Status:: FULL CAPACITY
Given Name:: Takeshi
Family Name:: YOSHIDA
City of Residence:: TOKYO
Country of Residence:: JAPAN
Street of Mailing Address:: c/o Renesas Technology Corp., 4-1,
Marunouchi 2-chome, Chiyoda-ku
City of Mailing Address:: TOKYO
Country of Mailing Address:: JAPAN

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2003-094542	Japan	03/31/03	YES

ASSIGNMENT INFORMATION

Assignee Name:: Renesas Technology Corp.
Street of Mailing Address:: 4-1, Marunouchi 2-chome,
City of Mailing Address:: Chiyoda-ku,
Country of Mailing Address:: TOKYO
JAPAN